

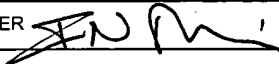
FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <b>INFORMATION DISCLOSURE STATEMENT          BY APPLICANT</b>  (USE SEVERAL SHEETS IF NECESSARY)	ATTY. DOCKET NO. GIVAR5.301APC.	APPLICATION NO. 09/674,415
	APPLICANT Givargizov et al.	
	FILING DATE April 30, 1999	GROUP Unknown

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
		5,090,932	2/25/92	Dieumegard et al.	445	24	
		5,188,977	2/23/93	Stengl, et al.	438	20	
		5,710,478	1/20/98	Kanemaru et al.	313	336	
		5,717,278	2/10/98	Bartha et al.	313	336	
		5,791,959	8/11/98	Bartha et al.	445	24	
		5,817,201	10/6/98	Greschner et al.	156	150	
		5,825,122	10/20/98	Givargizov et al.	313	336	

FOREIGN PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION		
							YES	NO	
		*							

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
	Givargizov, E. I., "22.3: A Field-Emission Lamp Based on Si Microstructures with Diamond Coating for LCD Backlighting", 1997 SID International Symposium Digest of Technical Papers, Boston, May 13-15, 1997, Nr. Vol. 28, Pages 369-372	
	Givargizov, E. I., "Ultrasharp Tips for Field Emission Applications Prepared By the Vapor-Liquid-Solid Growth Technique", Journal of Vacuum Science and technology, Part B, Vol 11, NR. 2, Pages 449-453, March/April 1993	
	Zhirnov, E.V. and Givargizov, E. I., "Chemical Vapor Deposition and Plasma-Enhanced Chemical Vapor Deposition Carbonization of Silicon Microtips", Journal of Vacuum Science and Technology, Part B, Vol 12, Nr. 2, Pages 633-637, March/April 1994.	

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EXAMINER 	DATE CONSIDERED 9/9/02
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	